

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Markus Schwambera, et al.
Serial No. 10/754,817	Filing Date: January 9, 2004
Title of Application:	Process Chamber with a Base with Sectionally Different Rotational Drive and Layer Deposition Method in Such a Process Chamber
Confirmation No. 1549	Art Unit: 1762
Examiner	

Mail Stop Amendment Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Election Pursuant to Restriction Requirement

This is a response to the Examiner's telephone conference on August 18, 2004 with Wesley W. Whitmyer, Jr. re an Election.

Applicants hereby elect the invention of apparatus Claims 2, 11-18 for prosecution in this case. Claims 1 and 3-6 are reserved for filing in a future application.

Respectfully submitted,

Wesley W. Whitmyer, Jr., Registration No. 33,558

Attorney for Applicants

ST.ONGE STEWARD JOHNSTON & REENS LLC

986 Bedford Street

Stamford, CT 06905-5619

203 324-6155

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner for Patents and Trademarks; Post Office Box 1459; Alexandria, VA 22313-1450.

September ______, 2004

Beatrice R. Emerson